

AF *EW*



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:
Mei, et al.

Serial No. 10/064,156

Filed: June 14, 2002

For: MODIFIED PHOTOLITHOGRAPHY
MOVEMENT SYSTEM

§ Group Art Unit: 2125
§
§ Examiner: Cabrera, Zoila E
§
§ Attorney Docket No. 22397.324
§
§
§
§

*OK to be
entered
2/19/06*

AMENDMENT

Mail Stop AF
Commissioner For Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Final Office Action mailed November 1, 2005, please amend the
above-identified patent application as follows:

Amendments to the claims begin on page 2 of this paper.

Remarks begin on page 4 of this paper.